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S/N 10/804610

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Applicant:	KITAOKA	Examiner:	TU TU V. HO
Serial No.:	10/804610	Group Art Unit:	2818
Filed:	March 18, 2004	Docket No.:	10873.1420US01
Title:	METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE AND SEMICONDUCTOR DEVICE		

CERTIFICATE UNDER 37 CFR 1.6(d)

I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on September 19, 2006.

By:

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Dear Sir:

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PATENT TRADEMARK OFFICE

Dated: September 19, 2006

Respectfully submitted,

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